

# NON LINEAR KICKER R&D AT SOLEIL *A.K.A.* MIK : MULTIPOLE INJECTION KICKER

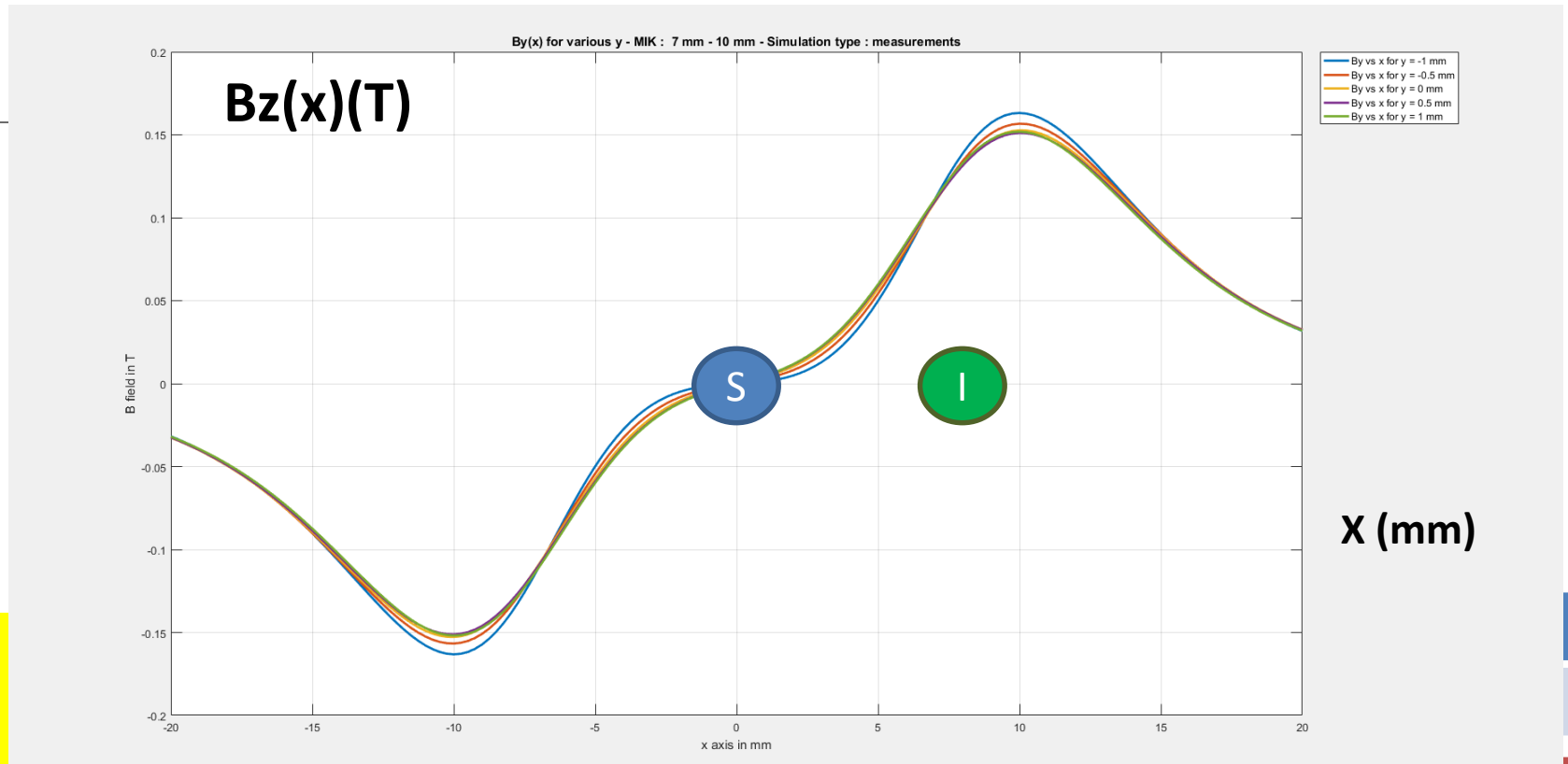
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*On behalf of the SOLEIL and MAX-IV teams on the  
development, construction and commissioning of the MIKs.*

## *What we are going to talk about ....*

- MAX-IV & SOLEIL collaboration.
- Top-Up injection with a Non Linear Kicker.
- Magnetic design of the MIK.
- Design and construction of the MIK system.
- Pulsed magnetic measurements.
- Conclusions.

- **Collaboration between MAX-IV in Sweden and SOLEIL in France (2012 – 2016/2017).**
- **Funded by the Swedish Ministry of Research.**
- **Aimed at researching and developing technology for accelerators:**
  - Control systems.
  - Nanobeamlines.
  - Insertion Devices.
  - Sample Environment.
  - Accelerator Devices.
  - Time Resolved Methods.
- **MIK project : 1 complete pulsed NLK for MAX-IV 3 GeV storage ring and 1 complete pulsed NLK for the SOLEIL 2.75 GeV storage ring.**
- ***This presentation (all figures) is about the MAX-IV 3 GeV MIK.***

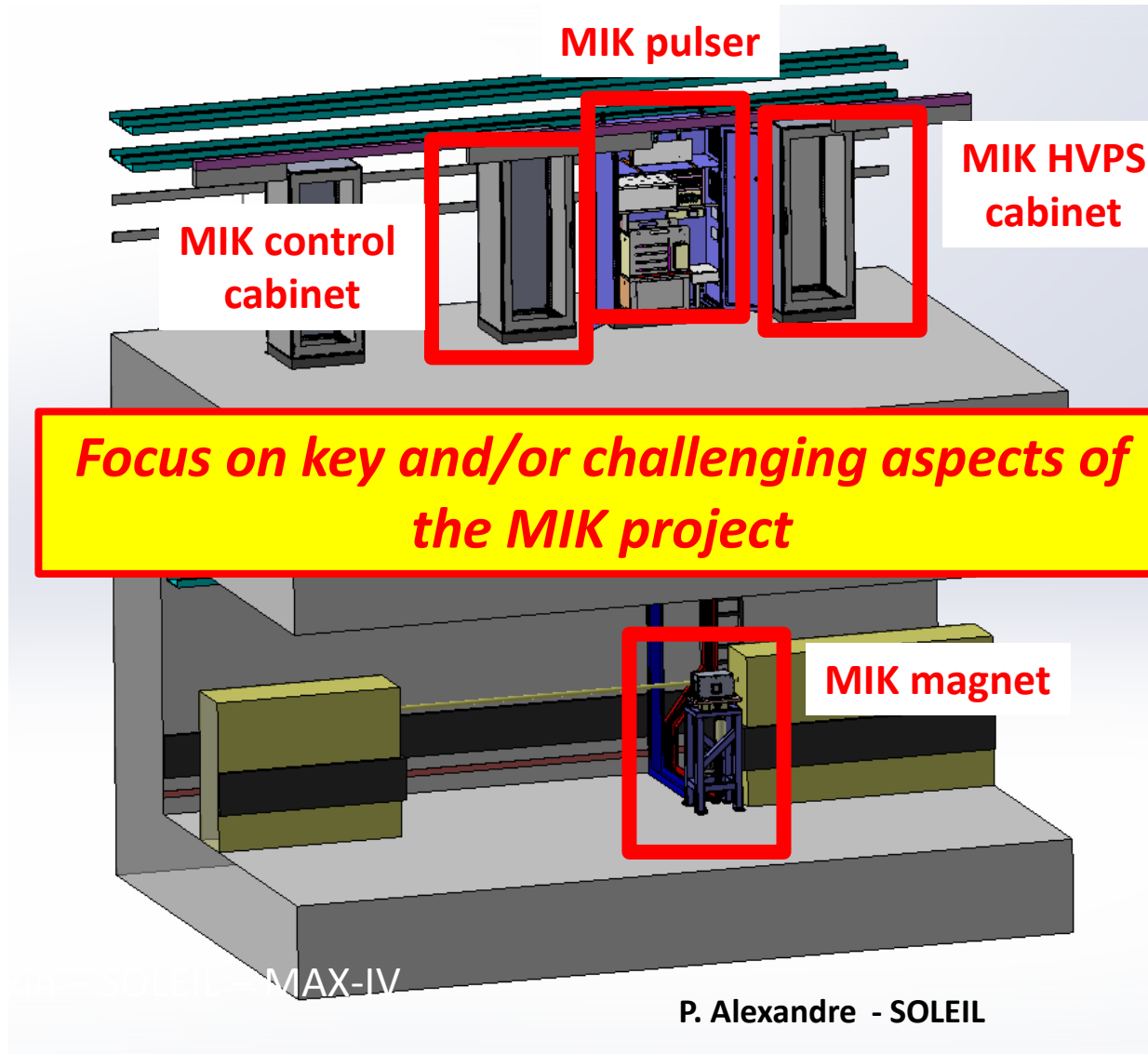


**Transparent  
Top-Up  
Specifications**

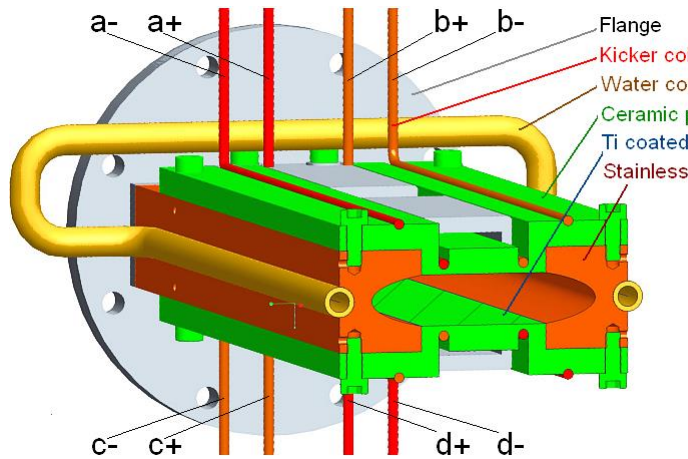
Pulse duration	Max. By Integrated Field at X = 0	Max. Bx Integrated Field at X = 0	Max. By Gradient at X = 0
3.5 $\mu$ s	5 $\mu$ Tm	1 $\mu$ Tm	0.3 T/m

*On a 96  $\mu$ m (H) x 21  $\mu$ m (V) window centered on stored beam.*

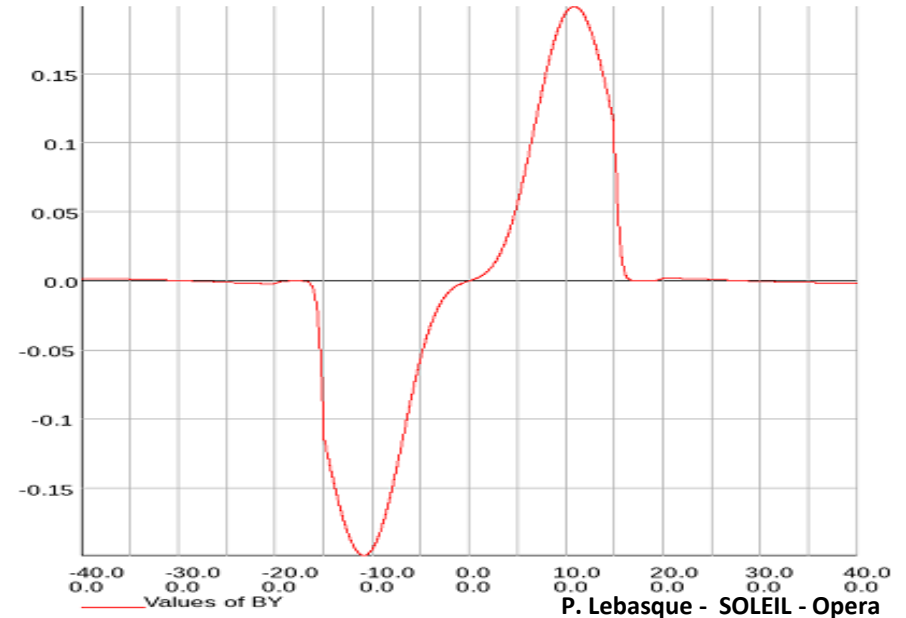
## MIK for MAX-IV 3 GeV : how it looks like !...



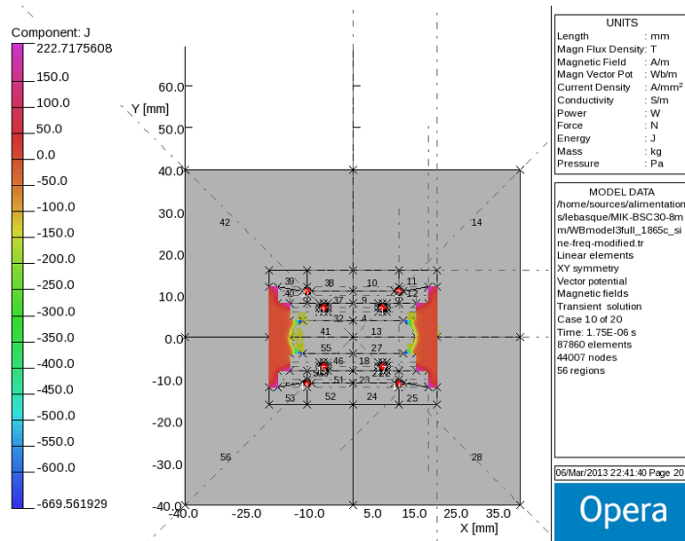
# Magnetic design of the MIK : starting from BESSY II NLK



O. Dressler – P. Kuske – BESSY II



P. Lebasque - SOLEIL - Opera



P. Lebasque - SOLEIL - Opera

- Avoid large metallic parts near magnetic fields.
- Coils connected in series.
- Position of 8 coils is critical.
- SR absorption / cooling .
- Titanium coating screening effect.

## Making a pulsed magnet system...

### DESIGNING IT

- **Accelerator physics** : injected beam position, integrated field, defect field at center, GFR, chamber apertures...
- **Magnet design** : simulation (DC & Transient : Opera & Matlab), effect of Ti coating on fields, inductance...
- **Thermal study** : image current & current in coils, mechanical stress in magnet/vacuum chamber...
- **Vacuum chamber design** : aperture (H&V), Synchrotron Radiation (SR) ray tracing, static and dynamic pressure simulations, outgassing of materials...
- **Pulser design** : high voltage (HV) pulsed electronics, choice of components, stability & reproducibility of the current pulse, HVPS, coaxial cable, EMC ...
- **Mechanical design** : magnet, pulser & HV insulator design, issues with alignment and metrology, vibration study, handling and installation ...
- **Materials choice** : issues with radiation, high voltage, ultra-high vacuum, availability, mechanical strength & expansion, etc...
- **Alignment and metrology** : measure the magnet to accurately place on the accelerator.
- **Control system design** : triggering, fault monitoring, interlock & safety...
- **Installation and commissioning** : when and how install it, baking, testing...
- **Operation** : ease of use / maintain, reliability..
- **Budget** : money doesn't grow on trees.

### BUILDING IT

- **Subcontract parts manufacturing** : which parts? control quality?
- **In-house manufacture** : who can do what ? availability, work planning...
- **Prototyping** : how much ? how far do you go ? how many tests ? what parts need prototyping ?
- **Manufacture management** : series/parallel work, test subsystems...
- **Final testing** : magnetic measurements, electrical tests, long duration tests, debugging...
- **Communicate** : reports on technical design & simulations, procedures for installation-troubleshooting-operation, feedback for/from other groups, forms, various paperwork...

### ITERATIVE WORK !

- **Find a solution** that meets some physics specifications -> check all the other aspects...
- **Check tolerance to manufacturing errors** for components, ruggedness of design...
- **New matters will rise !** You don't always foresee all the problems...
- **Until your solution works and meets all the implicit and explicit specifications...**
- **It takes a lot of people !**

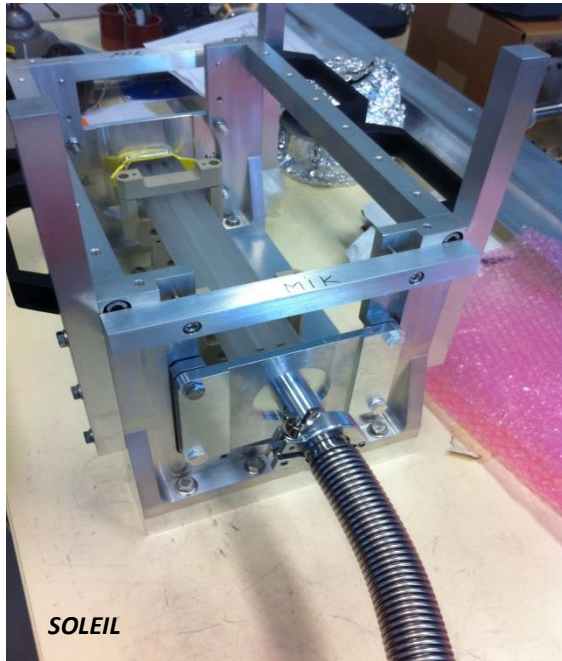
## Summary of main characteristics (3 GeV MIK)

- **7 mm – 10 mm** MIK structure.
- **8 copper rods** accurately positioned. Rods are **2 mm** in diameter.
- Aperture is **8 mm (V) x 46 mm (H)**.
- Length : 400 mm (flange to flange).
- Chamber is made of **alumina ceramic**.
- No large metallic parts near magnetic fields (except flanges with low permeability stainless steel).
- Current pulse : **7.8 kA @ 14 kV on magnet &  $\tau_{\text{pulse}} = 3.5 \mu\text{s}$** 
  - Detailed design of HV insulators & connexions in very confined spaces (range of mm).
- All 8 rods are connected in series : **inductance of 1  $\mu\text{H}$**
- Titanium coating : **1  $\mu\text{m}$** .
- Total heat load : **100 W** (full stored current & 10 Hz pulsed current repetition rate).
- Magnet is **embedded** in the vacuum chamber.
- Magnet construction split between in house made parts / assembly and subcontracted manufacture.
- Magnets are **identical** for both SOLEIL and MAX-IV storage rings.

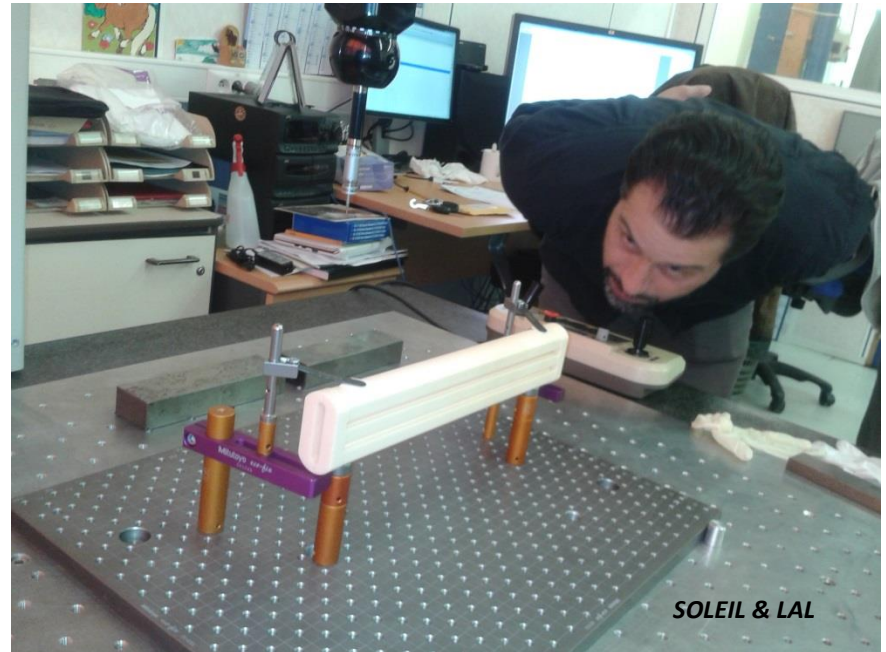


## Process of assembling the MIK magnet

**KYOCERA delivers bare chambers with steel adaptation end-parts**



**Preliminary vacuum tests :**  
**verify absence of large leaks.**  
**Proper tools & procedures to be**  
**developed**  
*(Vacuum group - SOLEIL – Gif-sur-Yvette)*



**Metrology of chambers :**  
**using tri-dimensional measurements**  
**verify quality of machining (grooves, aperture,**  
**etc..) with 3 different references.**  
*(B. Leluan – LAL – Orsay)*

## Process of assembling the MIK magnet

Once chambers are accepted...



**CF100 flange welding : UHV weld.  
Proper tools and procedures are  
developed & training parts made.  
(P. Prout - SOLEIL – Gif-sur-Yvette)**



**Titanium coating done at ESRF.  
Specific tools and procedure developed  
for small aperture & non conductive  
chambers.  
(M. Dubrulle – H. Marques - ESRF – Grenoble)**

## Process of assembling the MIK magnet

- Bending and preparing 8 copper rods.
- Gluing them !! Not so evident !!
- A lot of tools developed for all these steps.
- Procedures tried and tested on an aluminum chamber first, then revised, then put into action on the first real chamber.
- About 3 month procedure to go through until you get one magnet ready for electric and magnetic measurements & testing.

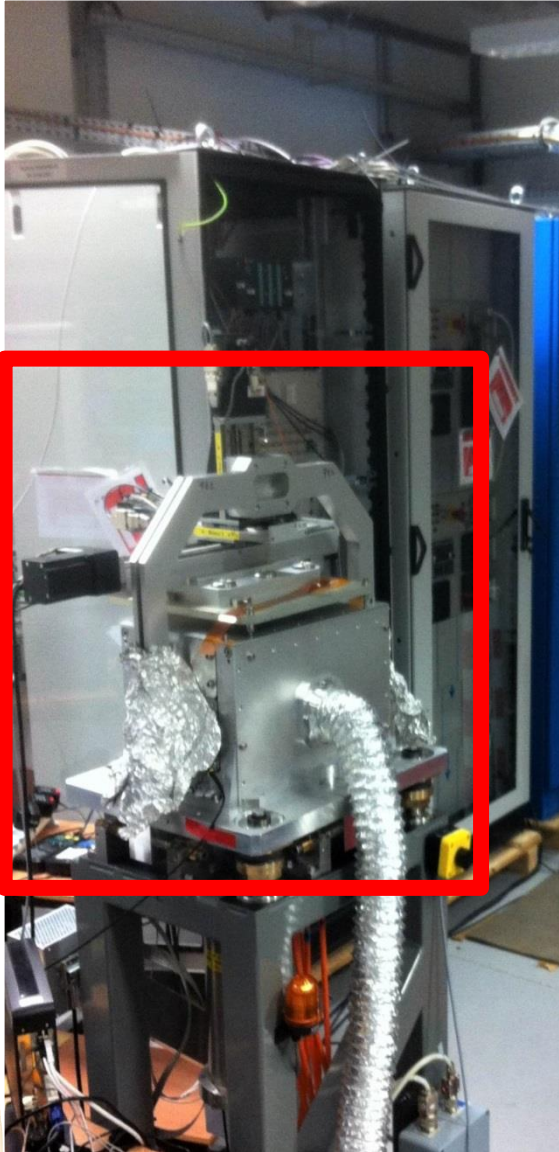
### *Classic capacitive resonant discharge into the magnet inductance*



- 1.3  $\mu\text{F}$  – 20 kV Leclanché capacitor bank.
- 4 HV IGBT Behlke modules (2400 A – 18 kV) in // and 20 kV series fast diodes.
- Resistor and diode cell.
- Resistor and capacitor cell.
- FuG 18kV – 280 mA charging power supply. (10 Hz repetition rate).
- Resistor and capacitor // on magnet inductance.
- 10 coaxial RG-214 cables.
- Pulser is electrically designed in-house.
- Pulser is mechanically designed in-house : high-voltage vs inductance vs maintainability constraints.

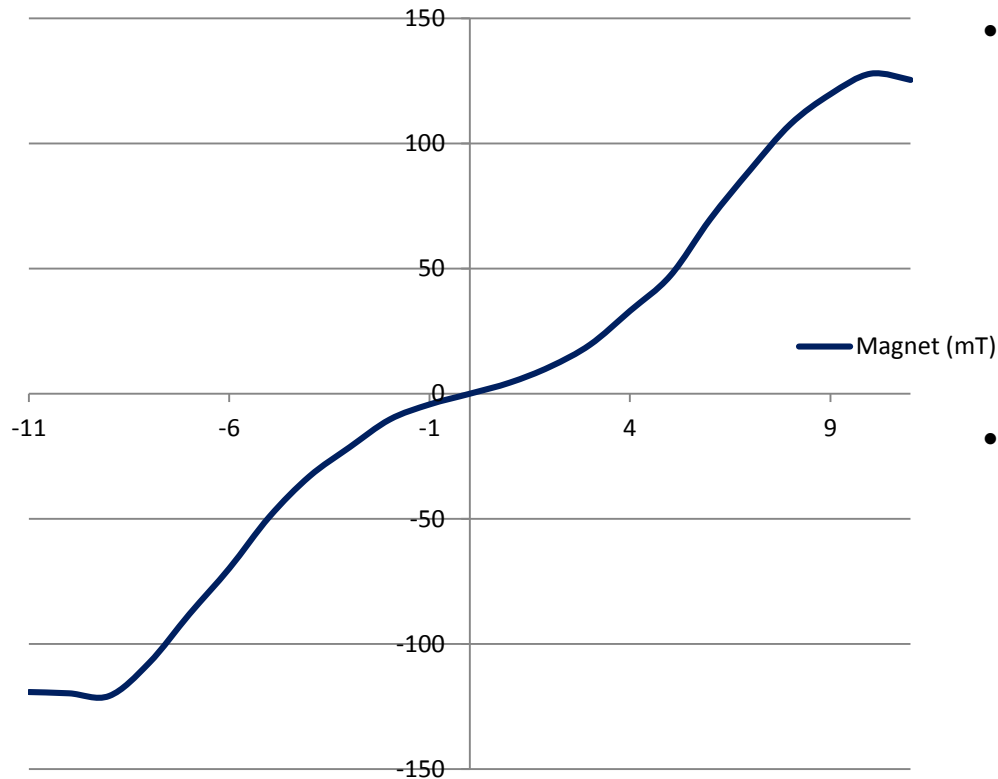
## Complete system and magnetic measurements

### *First results...*



- **No major issues with electrical insulation !**
- **Magnetic fields in MIK strongly depend on  $s$ ,  $x$  and  $y$ .**
- Magnetic measurements have to be **accurate** : in terms of magnetic component measured ( $B_s$ ,  $B_x$  &  $B_y$ ) and the location of the measurement.
- **Pulsed magnetic measurement bench redesigned and built :**
  - **Precise positioning in 3 dimensions** of the measurement probes (local & integral) done with stepper motors & precise mechanics.
  - **Straightness of the integral probe** so measurement is done for a known and constant  $x$  &  $y$  position along  $s$ .
  - **Precise (and long) alignment** of the bench on the magnet and testing displacements of probes (look-up table).
- After successful high voltage testing of the first magnet (made with rejected KYOCERA chamber), **the magnet was magnetically measured in July 2017.**

### By (x = -11 to + 11 mm & y = 0)



- Shape is as expected :
  - Peaks values at  $x \approx 10 \text{ mm} \approx b$  with value close to simulation.
  - **By at injection  $\approx 40 \text{ mT}$ .**
- Because rods not accurately positioned (rejected chamber due to out of tolerance machining), the zero field region is absent, as simulations predicted it.

## Conclusion

- **Extremely challenging** from the **accelerator physics specifications point of view.**
- Led to detailed engineering on multiple scales :
  - **Macroscopic** : dimensioning of the magnet, high peak current/short pulse/high voltage & insulation in very confined spaces.
  - **Microscopic** : effect of small machining error in positioning of rods on the magnetic fields quality.
- **Sapphire** used for a large vacuum chamber with very small tolerances on machining.
- Outstanding effort on **tool design & procedure** to go from bare chamber to complete magnet with minimum risk of failure with highly-skilled technicians.
- **Accurate pulsed magnetic measurement bench** gave good measurement on test chamber.
- **First magnetic tests extremely encouraging and we are looking forward to measure the « good » chambers once assembled !**

**SOLEIL (Gif-sur-Yvette)**

**Pulsed magnets** : P. Alexandre, R. Ben El Fekih, A. Letrésor, A. Hardy (*ret*), D. Muller, M. Bol.

**Mechanical Engineering** : J.L. Marlats (*ret*), J. Dasilvacastro, S. Thoraud, S. Genix, F. Lepage, P. Prout, C. DeOlivera, C. Basset (*ret*), N. Jobert.

**Vacuum** : C. Herbeaux, N. Béchu, S. Morand, N. Baron, V. Joyet.

**Electronics & Computer Control** : G. Renaud, P. Monteiro, X. Elattoui, T. Jablonka.

**Metrology and alignment** : A. Lestrade, C. Bourgoïn.

**Accelerator physics** : R. Nagaoka, A. Loulergue.

**Purchase & Juridical** : T. Bucaille, F. Minaeian, E. Monin.

**Collaborations** : N. Guimard.

*Et al...*

**General project leadership**

**P. Lebasque (SOLEIL)**

**P. Fernandes Tavares (MAX-IV)**

**MAX-IV (Lund)**

E. Al d'Mour, J. Ahlbäck, S. Leeman, M. Johansson, L. Dallin, B. Jenssen, K. Ahnberg, M. Grabski, M. Gunnarsson, V. Hardion, J. Thanel, J. Jamroz.

**BESSY II (Berlin)**

O. Dressler, P. Kuske.

**LAL (Orsay)**

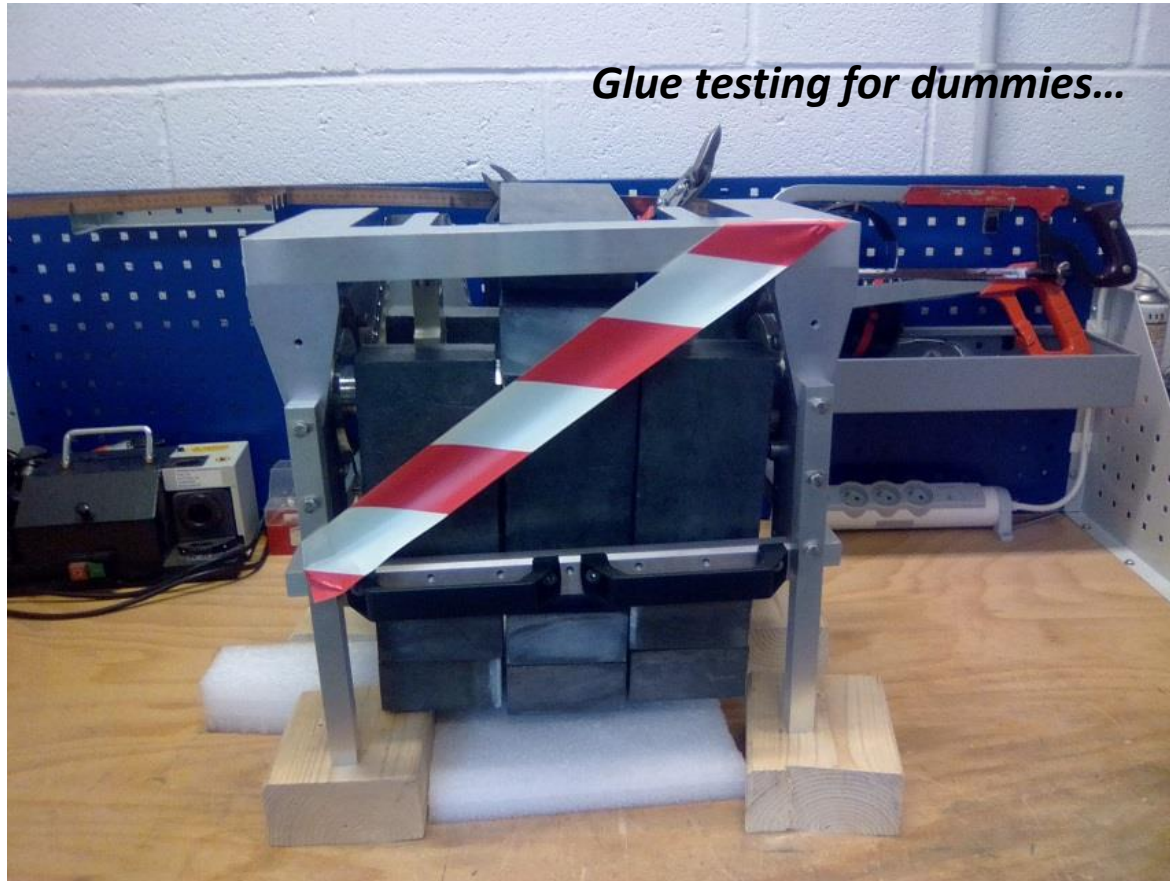
B. Leluan.

**ESRF (Grenoble)**

M. Dubrulle.

H. Marques.





**Thank you for your attention !**  
**Comments & questions more than welcome !**